

AMENDMENT TRANSMITTAL LETTER (Small Entity)

Applicant(s): Scherer et al.

Docket No.

CIT.PAU.01

Serial No.
10/068,283

SEP 27 2004

Filing Date
Feb. 5, 2002Examiner
R. McDonaldGroup Art Unit
1753

Invention: DRY ETCHING AND MIRROR DEPOSITION PROCESSES FOR SILICONE

ELASTOMER

O I P E
SEP 27 2004TO THE COMMISSIONER FOR PATENTS:

Transmitted herewith is an amendment in the above-identified application.

Small Entity status of this application has been established under 37 CFR 1.27 by a verified statement previously submitted.

A verified statement to establish Small Entity status under 37 CFR 1.27 is enclosed.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	23 -	20 =	3	x \$9.00	\$27.00
INDEP. CLAIMS	6 -	5 =	1	x \$43.00	\$43.00
Multiple Dependent Claims (check if applicable)		<input type="checkbox"/>			\$0.00
					TOTAL ADDITIONAL FEE FOR THIS AMENDMENT
					\$70.00

No additional fee is required for amendment.

Please charge Deposit Account No. _____ in the amount of _____.

A check in the amount of \$70.00 to cover the filing fee is enclosed.

The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. _____.

Any additional filing fees required under 37 C.F.R. 1.16.

Any patent application processing fees under 37 CFR 1.17.

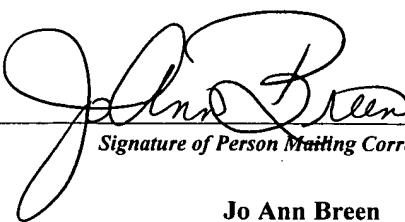


Signature

Dated: September 23, 2004

Daniel L. Dawes, Reg. No. 27,123
 MYERS DAWES ANDRAS & SHERMAN LLP
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 Irvine, California 92612

I certify that this document and fee is being deposited on September 23, 2004 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.



Signature of Person Mailing Correspondence

Jo Ann Breen

Typed or Printed Name of Person Mailing Correspondence

CC:



IFW AF/BS
Patent
CIT.PAU.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Scherer et.al.

Serial No.: 10/068,283

Filed: Feb. 5, 2002

For: Dry Etching and Mirror
Deposition Processes for Silicone
Elastomer

Examiner: R.McDonald
Group Art Unit: 1753

AMENDMENT AFTER FINAL

Hon. Commissioner of Patents and Trademarks
Washington DC 20231

Sir:

In reply to the Office Sept. 10, 2004, please consider the following
remarks and enter the following amendments. Enclosed is a check for
additional claims added by this amendment.

Amendments to the Claims are reflected in the listing of claims which
begins on page 2 this paper.

Remarks begin on page 8 of this paper.

09/28/2004 FMETEK11 00000013 10068283

01 FC:2201

43.00 OP
02 FC:2202